

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No: To Be Assigned
Applicant: Ming Li et al.
Filed: Herewith
Title: ULTRAFast LASER DIRECT WRITING METHOD FOR MODIFYING EXISTING
MICROSTRUCTURES ON A SUBMICRON SCALE
TC/A.U.: To Be Assigned
Examiner: To Be Assigned
Docket No.: MATG-401US

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98 and to the duty of disclosure set forth in 37 C.F.R. § 1.56, the Examiner in charge of the above-identified application is requested to consider and make of record the references listed on the PTO 1449 (RP) submitted herewith. A copy of each of the listed references is also enclosed.

Although the information submitted herewith may be "material" to the Examiner's consideration of the subject application, this submission is not intended to constitute an admission that such information is "prior art" as to the claimed invention.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made.

This Information Disclosure Statement is being filed concurrently with the above-referenced application.

Respectfully submitted,



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KNN/tmb

Enclosures: PTO Form 1449
(2) References

Dated: March 1, 2004

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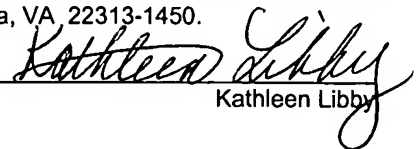
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Kathleen Libby

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Substitute for Form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>	Complete if Known	
	Application Number	To Be Assigned
	Filing Date	Herewith
	First Named Inventor	Ming Li et al.
	Art Unit	To Be Assigned
	Examiner Name	To Be Assigned
SHEET 1 of 1	Attorney Docket No.	MATG-401US

NON-PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (In CAPITAL LETTERS), title of the article (when appropriate), title of the Item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-Issue number(s), publisher, city and/or country where published	T ²	
	1.	MING LI ET AL., Nanostructuring in submicron-level waveguides with femtosecond laser pulses, Optics Communications, Elsevier Science B.V., September 2002, (5 pgs.)	<input type="checkbox"/>	
	2.	MING LI ET AL., Ultra-precision machining using fs fast Laser: An application for Photonic Crystal fabrication, Fs Ultra-maching Workshop, March 5, 2003, (53 pgs.)	<input type="checkbox"/>	
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Examiner Signature			Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

¹Applicant's unique citation designation number (optional).

²Applicant is to place a check mark here if English language translation is attached.

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